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Customer No. 026418

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Attorney's Docket No.: GK-OEH-218 / 500814.20120

U.S. Application No.:

International Application No.: PCT/DE2004/001171

International Filing Date: JUNE 04, 2004

04 JUNE 2004

Priority Date Claimed: JUNE 05, 2003

05 JUNE 2003

Title of Invention:

METHOD FOR THE STRUCTURED METAL-COATING OF POLYMERIC AND CERAMIC SUPPORT MATERIALS, AND COMPOUND THAT CAN BE ACTIVATED AND IS USED IN SAID METHOD

Applicant(s) for
(DO/EO/US):

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Mail Stop PCT
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-450

INFORMATION DISCLOSURE STATEMENT

S I R:

Applicant herewith submits together with the simultaneously filed National Phase application of PCT/DE2004/001171, a copy of the International Search Report (PCT/ISA/210) dated October 11, 2004, citing some of the following references:

	Document Number	Date	Name and/or Country	English Translation and/or Equivalent
AA	6,210,537	04/03/2001	Murphy, et al.	
AB	6,319,564	11/20/2001	Naundorf, et al	
AL	0 340 513	11/08/1989	European	Abstract only
AM	38 43 230	09/21/1989	Germany	Abstract only
AN	0 349 946	01/10/1990	European	Abstract only
AO	41 24 686	01/30/1992	Germany	Abstract only
AP	0 647 729	04/12/1995	European	Abstract only
AQ	0 710 062	05/01/1996	European	n/a
AR	WO 99/05895	02/04/1999	WIPO	Abstract only
AS	0 965 656	12/22/1999	European	Abstract only
AT	198 35 158	02/10/2000	Germany	Abstract only
AU	WO 00/35259	06/15/2000	WIPO	Abstract only

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OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

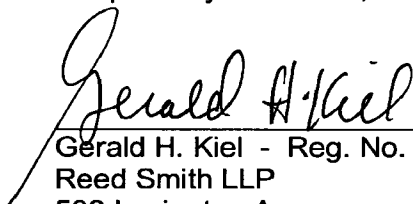
- AX "VUV synchrotron radiation processing of thin palladium acetate spin-on films for metallic surface patterning", *Applied Surface Science*, Vol. 46 (1990) pages 153-157
- AY "LAD – a novel, laser-assisted coating process for very-fine conductor metallization", *Galvanotechnik*, No. 10, V81 (1990), page 3661
- AZ Spritzgegossene Formteile mit strukturiertem Leiterbild, *Trends in der MID-Technologie*, Galvanotechnik, MO Jahrg.54 (2000) 8 Carl Hanser Verlag, Muenchen , pages 23--27

Accompanying this Information Disclosure Statement and form PTO-1449 are copies of the documents including English Abstracts. Documents AB, AO, AR, AS, AX and AY are mentioned on pages 1 and 2 of the substitute specification.

The USPTO waived the requirement under 37 C.F.R. §1.98(a)(2)(i) for submitting copies of US patents and US patent application publications in all U.S. applications filed after June 30, 2003. First pages of US documents only.

This submission is not an admission that the information disclosed in the documents is material to the patentability of the invention disclosed and/or claimed in the above-identified application.

Respectfully submitted,



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Enclosures:

Search Report (PCT/ISA/210)
PTO-1449
2 first pages US Patents
10 foreign documents w/9 English Abstracts
3 Articles

LIST OF PRIOR ART CITED BY APPLICANT
(Filed on December 2, 2005)

PTO-1449 Equivalent

10/559112

Docket No. **GK-OEH-218/500814.20120**

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Applicant(s): **Mario SCHOEDNER, Hans-Klaus ROTH and Gulnara NASMUTDINOVA**

Application No. **10/559,112** (Int'l Appln No. **PCT/DE2004/001171** 04JUN04) Group: **1792**

Filed: **Concurrently herewith – December 2, 2005**

Examiner: **R. Culbert**

U.S. PATENT DOCUMENTS

Exam. Init		Document Number	Date	Name	Class	Sub-Class	Filing Date Appropriate
/RC/	AA	6,210,537	04/03/2001	Murphy, et al.			
/RC/	AB	6,319,564	11/20/2001	Naundorf, et al			
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	CLASS	Sub-Class	Translation YES NO
/RC/	AL	0 340 513	11/08/1989	European			Abstract only
/RC/	AM	38 43 230	09/21/1989	Germany			Abstract only
/RC/	AN	0 349 946	01/10/1990	European			Abstract only
/RC/	AO	41 24 686	01/30/1992	Germany			Abstract only
/RC/	AP	0 647 729	04/12/1995	European			Abstract only
/RC/	AQ	0 710 062	05/01/1996	European			n/a
/RC/	AR	WO 99/05895	02/04/1999	WIPO			Abstract only
/RC/	AS	0 965 656	12/22/1999	European			Abstract only
/RC/	AT	198 35 158	02/10/2000	Germany			Abstract only
/RC/	AU	WO 00/35259	06/15/2000	WIPO			Abstract only

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/RC/	AX	"VUV synchrotron radiation processing of thin palladium acetate spin-on films for metallic surface patterning", <i>Applied Surface Science</i>, Vol. 46 (1990) pages 153-157
/RC/	AY	"LAD – a novel, laser-assisted coating process for very-fine conductor metallization", <i>Galvanotechnik</i>, No. 10, V81 (1990), page 3661
/RC/	AZ	Spritzgegossene Formteile mit strukturiertem Leiterbild, Trends in der MID-Technologie, Galvanotechnik, MO Jahrg.54 (2000) 8 Carl Hanser Verlag, Muenchen , pages 23--27

Examiner: **/Roberts Culbert/**

Date: **01/21/2008**

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.